

## DREAM Event Selection

Tom Coates, **Samuel Jones**,  
Fabrizio Salvatore, Iacopo Vivarelli

University of Sussex

November 7, 2018

US

University of Sussex

## Event Selection

- Design two independent event selections based on:
  - Calorimeter deposits
  - Ancillary detectors
- Total events from a run:  $N = N_e + N_h + N_\mu$
- Event yield  $k_i$  for a given particle given approximately by:

$$\begin{pmatrix} k_e \\ k_h \\ k_\mu \end{pmatrix} = \Lambda \cdot \begin{pmatrix} N_e \\ N_h \\ N_\mu \end{pmatrix}; \quad \Lambda = \begin{pmatrix} \epsilon_e & f_e^h & f_e^\mu \\ f_h^e & \epsilon_h & f_h^\mu \\ f_\mu^e & f_\mu^h & \epsilon_\mu \end{pmatrix}$$

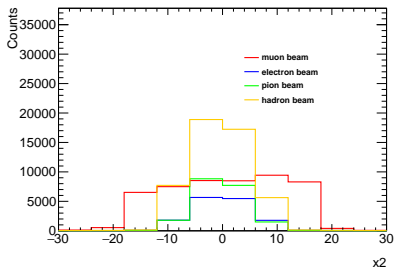
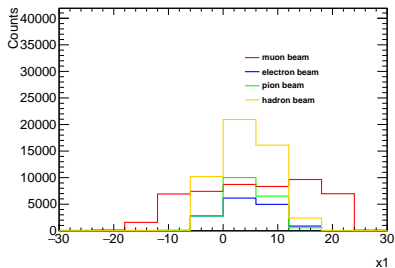
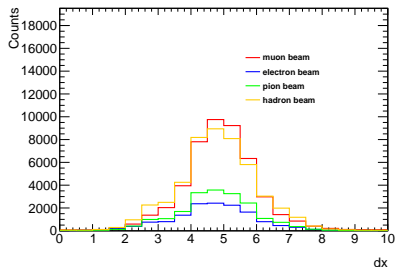
- By measuring the elements of  $\Lambda$  we can relate the  $k$ s and  $N$ s for ancillary selections
  - Measure ancillary selection efficiencies using tight calorimeter selections

## Runs used in this study:

Composition	Run No.	Energy	Note
Electron	12709	20	Veto In, Cal in Tw15, 0 mm Pb + 5mm PS
Pion (secondary beam)	12508	80	-
Muon	12686	40	No Veto, Cal in Tw31
Hadron	12802	60	-

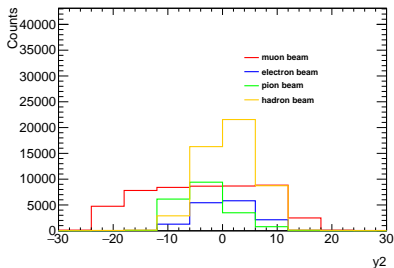
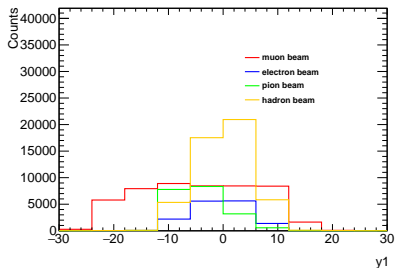
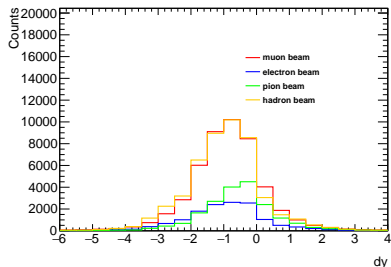
## Beam position

- No selection applied in plots
- Muon beam broader than other compositions
- $\Delta x$  approximately Gaussian
- $\sim 5\text{mm}$  offset between  $x_1$  and  $x_2$ 
  - Calibrate position by mean position over a run



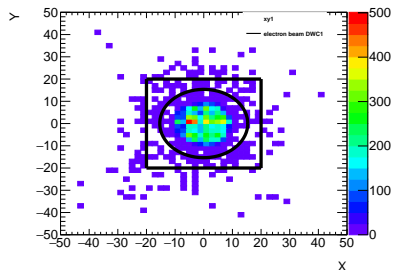
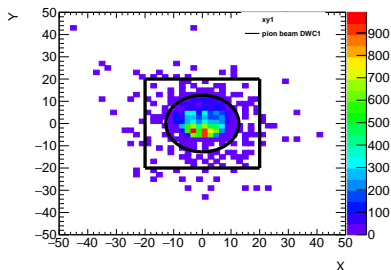
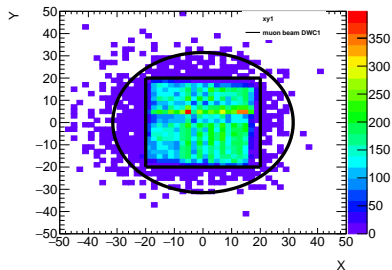
## Beam position

- No selection applied in plots
- Muon beam broader than other compositions
- $\Delta y$  approximately Gaussian
- Offset is run dependent
  - Calibrate position by mean position over a run



## Beam position

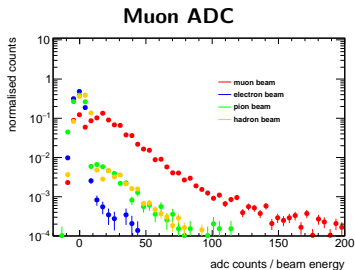
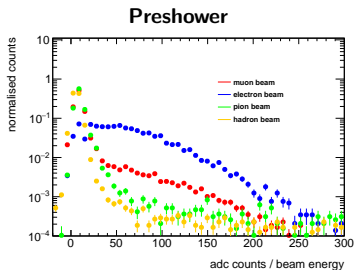
- Using calibrated  $x$  and  $y$  positions to plot beam profile
- Remove outliers from average beam position:  $\mu \pm 3\sigma$
- Muon beam is fairly evenly distributed
  - Remove events that lie outside apparent limits
- TODO: Use to track  $\Delta\theta$  from beam angle



## Ancillary Selection

- Beam outliers removed in plots
- Mean pedestal for run is subtracted
- Suggest the following selections:

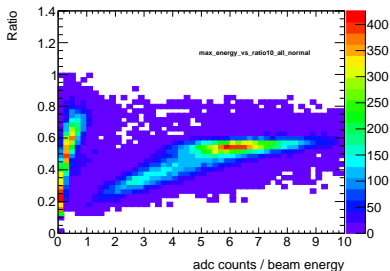
	preshower	muon ADC
electron	$> 20$	$< 8$
muon	$< 20$	$> 10$
pion	$< 20$	$< 5$



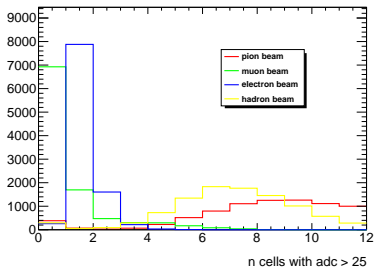
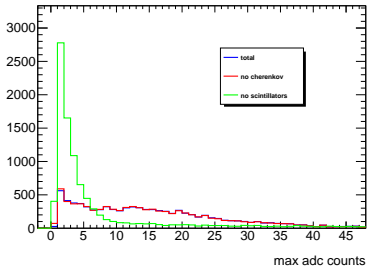
## Calorimeter Selection

- Beam outliers removed
- Mean pedestal for run is subtracted
- Small response to muons - almost no energy deposited in cherenkov
- Energy ratio & shower shape variables distorted for muons
- $N_{\text{cells}} > 25 = 0$  very pure for muons

$$\text{Ratio } R = Q_{\text{max}} / \sum_{10} Q_{\text{max}}$$



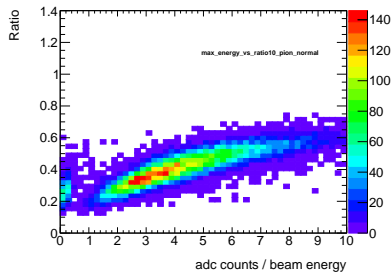
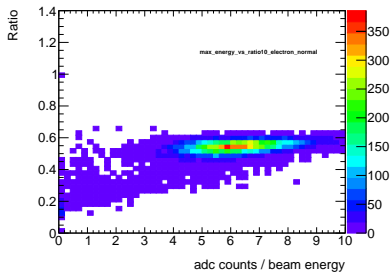
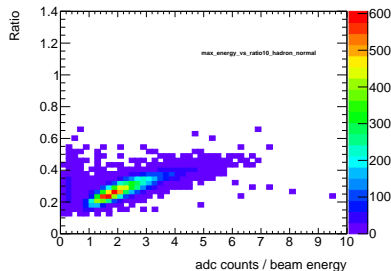
## Muon Beam



## Calorimeter Selection

- Apply tight selection to obtain high purity samples - to be used for ancillary efficiency estimate
- Divide electrons and hadrons using maximum energy and ratio

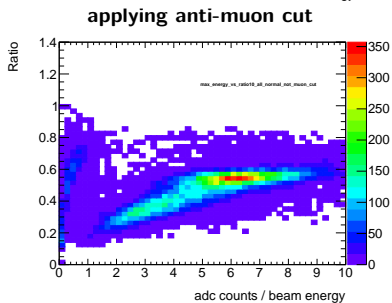
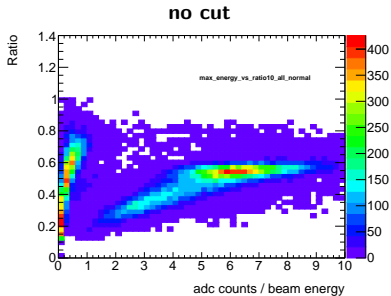
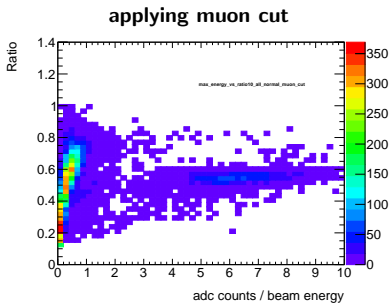
	$\text{max adc} / E_{\text{beam}}$	$N_{\text{cells}} > 25$	$R$
electron	$> 5$	2 – 5	0.55 – 0.6
muon	(0, 1)	0 – 1	-
pion	(2, 4)	$> 4$	0.0 – 0.4





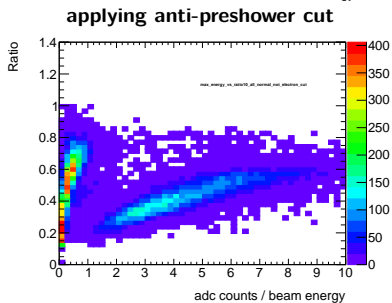
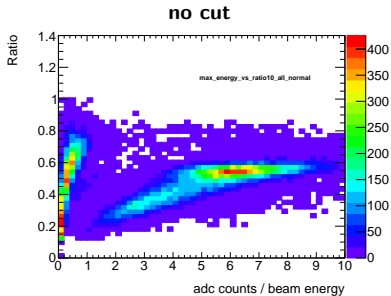
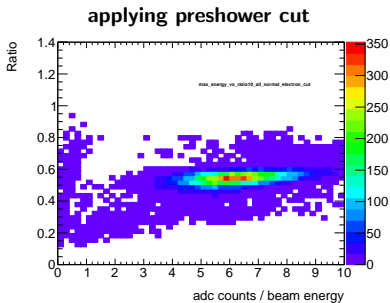
## calorimeter selection + ancillary selection

- Compare distributions before and after applying muon adc cut



## calorimeter selection + ancillary selection

- Compare distributions before and after applying preshower cut



## Determination of $\Lambda$

- To measure  $\epsilon_j$ , apply  $i$ th calorimeter selection to beam of composition  $i$  to obtain high purity sample
  - Then apply ancillary selection to measure the efficiency
  - The fake rate  $f_j^i$  is then the  $j$ th selection applied to the same sample

$$\Lambda = \begin{pmatrix} \epsilon_e & f_e^h & f_e^\mu \\ f_h^e & \epsilon_h & f_h^\mu \\ f_\mu^e & f_\mu^h & \epsilon_\mu \end{pmatrix}$$

## Determination of $\Lambda$ - results

$$\Lambda = \begin{pmatrix} 0.858 & 0.090 & 0.012 \\ 0.140 & 0.877 & 0.151 \\ 0.002 & 0.033 & 0.803 \end{pmatrix}$$

## Determination of $\Lambda$ - results (varying beams)

80 GeV pion beam  $\rightarrow$  60 GeV hadron beam

40 GeV muon beam  $\rightarrow$  60 GeV muon beam

$$\Lambda = \begin{pmatrix} 0.745 & 0.000 & 0.005 \\ 0.245 & 0.788 & 0.233 \\ 0.000 & 0.034 & 0.700 \end{pmatrix}$$

## Conclusions

- Designed a selection based on ancillary detectors - to be finalised
- Determined efficiencies and fake rates from calorimeter selection
- TODOs:
  - Unstable when varying beam energies - need to investigate
  - Estimate uncertainties on  $\Lambda$  matrix, beam compositions
  - Add tracking,  $\Delta\phi$ , deviation from beam angle
  - Implement the final selection in the merging code

# Backup